Artem Ivanov

List of Publications by Year in descending order

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1478505 1281871 13 116 11 6 citations h-index g-index papers 13 13 13 97 all docs docs citations times ranked citing authors

#	Article	IF	CITATIONS
1	Fluorinated graphene suspension for flexible and printed electronics: Flakes, 2D films, and heterostructures. Materials and Design, 2019, 164, 107526.	7.0	27
2	Two-layer and composite films based on oxidized and fluorinated graphene. Physical Chemistry Chemical Physics, 2017, 19, 19010-19020.	2.8	19
3	Resistive switching effects in fluorinated graphene films with graphene quantum dots enhanced by polyvinyl alcohol. Nanotechnology, 2019, 30, 255701.	2.6	14
4	Graphene Flakes for Electronic Applications: DC Plasma Jet-Assisted Synthesis. Nanomaterials, 2020, 10, 2050.	4.1	10
5	Fluorinated graphene nanoparticles with $1\hat{a}\in$ 3 nm electrically active graphene quantum dots. Nanotechnology, 2020, 31, 295602.	2.6	8
6	Resistive Switching Effect with ON/OFF Current Relation up to 10 ⁹ in 2D Printed Composite Films of Fluorinated Graphene with V ₂ O ₅ Nanoparticles. Advanced Electronic Materials, 2019, 5, 1900310.	5.1	7
7	Flexibility of Fluorinated Graphene-Based Materials. Materials, 2020, 13, 1032.	2.9	7
8	Resistive switching on individual V ₂ O ₅ nanoparticles encapsulated in fluorinated graphene films. Physical Chemistry Chemical Physics, 2021, 23, 20434-20443.	2.8	7
9	Graphene: Hexagonal Boron Nitride Composite Films with Low-Resistance for Flexible Electronics. Nanomaterials, 2022, 12, 1703.	4.1	7
10	Graphene/Hexagonal Boron Nitride Composite Nanoparticles for 2D Printing Technologies. Advanced Engineering Materials, 2022, 24, 2100917.	3.5	5
11	Mechanism of resistive switching in films based on partially fluorinated graphene. Semiconductors, 2017, 51, 1306-1312.	0.5	3
12	Neurointerfaces: Review and development. Russian Journal of Genetics: Applied Research, 2015, 5, 552-561.	0.4	2
13	Memristive FG–PVA Structures Fabricated with the Use of High Energy Xe Ion Irradiation. Materials, 2022, 15, 2085.	2.9	0